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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/003,347	12/06/2001	Zeev Smilansky	Q67625	6579
32588	7590 07/06/2004		EXAMINER .	
APPLIED MATERIALS, INC.			BALI, VIKKRAM	
2881 SCOTT BLVD. M/S 2061 SANTA CLARA, CA 95050			ART UNIT	PAPER NUMBER
	·		2623	0.
			DATE MAILED: 07/06/2004	9

Please find below and/or attached an Office communication concerning this application or proceeding.

,	Application No.	Applicant(s)
	10/003,347	SMILANSKY ET AL.
Office Action Summary	Examiner	Art Unit
	Vikkram Bali	2623
The MAILING DATE of this communication app Period for Reply	ears on the cover sheet with the c	orrespondence address
A SHORTENED STATUTORY PERIOD FOR REPLY THE MAILING DATE OF THIS COMMUNICATION.  - Extensions of time may be available under the provisions of 37 CFR 1.13 after SIX (6) MONTHS from the mailing date of this communication.  - If the period for reply specified above is less than thirty (30) days, a reply If NO period for reply is specified above, the maximum statutory period work. Failure to reply within the set or extended period for reply will, by statute, Any reply received by the Office later than three months after the mailing earned patent term adjustment. See 37 CFR 1.704(b).	6(a). In no event, however, may a reply be tim within the statutory minimum of thirty (30) days ill apply and will expire SIX (6) MONTHS from cause the application to become ABANDONE	nely filed s will be considered timely. the mailing date of this communication. D (35 U.S.C. § 133).
Status		
1) Responsive to communication(s) filed on	<u>.</u> .	
	action is non-final.	
3) Since this application is in condition for allowan closed in accordance with the practice under E.	•	
Disposition of Claims		
4) ☐ Claim(s) 1-4 and 26-29 is/are pending in the ap 4a) Of the above claim(s) is/are withdraw 5) ☐ Claim(s) is/are allowed. 6) ☐ Claim(s) 1-4 and 26-29 is/are rejected. 7) ☐ Claim(s) is/are objected to. 8) ☐ Claim(s) are subject to restriction and/or	n from consideration.	
Application Papers		
9)☐ The specification is objected to by the Examiner		
10) ☐ The drawing(s) filed on is/are: a) ☐ acce	pted or b) objected to by the E	Examiner.
Applicant may not request that any objection to the o	Irawing(s) be held in abeyance. See	e 37 CFR 1.85(a).
Replacement drawing sheet(s) including the correction 11) The oath or declaration is objected to by the Example 11.		• •
Priority under 35 U.S.C. § 119		
12) Acknowledgment is made of a claim for foreign a) All b) Some * c) None of:  1. Certified copies of the priority documents 2. Certified copies of the priority documents 3. Copies of the certified copies of the priori application from the International Bureau * See the attached detailed Office action for a list of	have been received. have been received in Application ty documents have been received (PCT Rule 17.2(a)).	on No ed in this National Stage
Attachmont(c)		
Attachment(s)	. 4) Interview Summary	(PTO-413)
Notice of Draftsperson's Patent Drawing Review (PTO-948)  Information Disclosure Statement(s) (PTO-1449 or PTO/SB/08)  Paper No(s)/Mail Date	Paper No(s)/Mail Da	

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### **DETAILED ACTION**

In response to the Remarks filled 5/28/2004 the action follows:

### Claim Rejections - 35 USC § 103

- 1. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
  - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 2. This application currently names joint inventors. In considering patentability of the claims under 35 U.S.C. 103(a), the examiner presumes that the subject matter of the various claims was commonly owned at the time any inventions covered therein were made absent any evidence to the contrary. Applicant is advised of the obligation under 37 CFR 1.56 to point out the inventor and invention dates of each claim that was not commonly owned at the time a later invention was made in order for the examiner to consider the applicability of 35 U.S.C. 103(c) and potential 35 U.S.C. 102(e), (f) or (g) prior art under 35 U.S.C. 103(a).
- 3. Claims 1-4 and 26-29 are rejected under 35 U.S.C. 103(a) as being unpatentable over Alumot et al (US 5699447) in view of Tsai et al (US 4845558).

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With respect to claims 1-4 and 26-29 the rejections are respectfully maintained and incorporated with reference as set forth in the previous office action paper number 18.

## Response to Arguments

4. Applicant's arguments filed 5/28/2004 have been fully considered but they are not persuasive.

Applicant argues that the references fail to disclose the pixel alone responds to the light of a scanning beam without reference to adjacent pixels (see page 3 paragraph 3). Examiner disagrees and would like to point out that the claim limitations are given their broadest reasonable interpretations. In the instant case, Alumot discloses method for detection of defects on semiconductor wafers, (see col. 12, lines 1-7) that explains the methodology of getting the reference by computing the type of each pixel "individual pixel" and the same methodology is performed during the inspection process, and "under control" is read as the area under investigation or inspection, defined by the way in which the pixel responds to the light of a scanning beam, (col. 1, lines 15-19, states that the photo detector detects the presence of a particle by collecting the light scattered by the particles i.e. the light scattered is read as "pixel responds to the light scanning beam"). And, Tsai in the wafer defect detection method teaches a pixel by pixel comparison for detecting the defects on the wafer, thereby teaching "the pixel alone and the without reference to adjacent pixels, for the signature of the pixel", (see col. 3, lines

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42-52, because the pixel to pixel is compared therefore, the signatures on a alone pixel is taken without referencing the adjacent pixels) as claimed.

It would have been obvious to one ordinary skilled in the art at the time of invention to combine the two references because they are analogous, because they are solving the similar problem of wafer inspection. The pixel-by-pixel inspection as taught by the Tsai can be incorporated into the Alumot system, and the motivation of doing thus is to make the comparison more accurate because the smallest element of the picture i.e. pixel, is compared.

#### Conclusion

5. **THIS ACTION IS MADE FINAL.** Applicant is reminded of the extension of time policy as set forth in 37 CFR 1.136(a).

A shortened statutory period for reply to this final action is set to expire THREE MONTHS from the mailing date of this action. In the event a first reply is filed within TWO MONTHS of the mailing date of this final action and the advisory action is not mailed until after the end of the THREE-MONTH shortened statutory period, then the shortened statutory period will expire on the date the advisory action is mailed, and any extension fee pursuant to 37 CFR 1.136(a) will be calculated from the mailing date of the advisory action. In no event, however, will the statutory period for reply expire later than SIX MONTHS from the mailing date of this final action.

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Any inquiry concerning this communication or earlier communications from the examiner should be directed to Vikkram Bali whose telephone number is 703.305.4510. The examiner can normally be reached on 7:30 AM - 4:00 PM.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Amelia Au can be reached on 703.308.6604. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Vikkram Bali

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vb July 1, 2004